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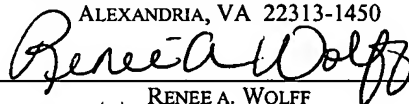
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Oikari et al.	Examiner: Carillo, Bibi Sharidan
Serial No.: 10/613,931	Group Art Unit: 1746
Filed: July 3, 2003	Docket No.: FSI0111/US
For: WAFER PROCESSING USING GASEOUS ANTISTATIC AGENT DURING DRYING PHASE TO CONTROL CHARGE BUILD- UP	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
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I CERTIFY THAT ON 12 August 2005, THIS PAPER
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RENEE A. WOLFF

INFORMATION DISCLOSURE STATEMENT

The documents listed on the enclosed Form PTO-1449 are presented pursuant to Applicant's duty of disclosure under 37 C.F.R. 1.56. In accordance with 37 C.F.R. 1.98(a)(2), enclosed is a copy of each of the foreign patents and non-patent publications. The Examiner is requested to indicate consideration of each reference by initialing in the appropriate box for each reference, and returning an initialed copy with the next Official Action.

No fee is believed to be necessary for the consideration of this Information Disclosure Statement since it is being filed before the receipt of an Office Action on the merits. In case the papers cross in the mail, it is requested that consideration of this Information Disclosure Statement be given under 37 C.F.R. § 1.97 (c)(2). If any fee is required, please charge our Deposit Account No. 50-1775 and notify us of the same.

Respectfully Submitted,

Dated: 12 AUG 05By: 

Kevin J. Hubbard, Reg. No. 50,717

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Form PTO-1449 U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No.	Serial No.
	FSI0111/US	10/613,931
	Applicant	
	Oikari et al.	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Filing Date	Group
	July 3, 2003	1746

U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
		5,336,371	08-09-1994	Chung et al.			
		5,451,291	09-19-1995	Park et al.			
		5,651,834	07-29-1997	Jon et al.			
		5,928,434	07-27-1999	Goenka			
		6,199,298	03-13-2001	Bergman			
		6,367,490	04-09-2002	Namba			
		6,589,359	07-08-2003	Kamikawa et al.			
		6,843,857	01-18-2005	Bergman			
		6,890,864	05-10-2005	Aoki et al.			

FOREIGN PATENT DOCUMENTS							
	Name	Document Number	Date	Country	Class	Subclass	Translation Yes/No
							No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.